

ATOMIC PROCESSES IN HELIUM-KRYPTON AND HELIUM-XENON MIXTURES

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ABSTRACT

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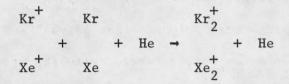
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The momentum transfer collision frequency of thermal electrons with neutrals in a decaying plasma established in helium-krypton and helium-xenon mixtures of known proportions were measured by microwave interferometer at gas temperatures of \sim 200 to 600°K. The energy dependences of the momentum transfer cross sections of electrons with krypton and xenon atoms deduced from these measurements are best represented by: $Q_{u}(u) = 6.56 \times 10^{-15} - 2.79 \times 10^{-14} u^{\frac{1}{2}} + 3.14 \times 10^{-14} u$ and $1.91 \times 10^{-14} - 8.30 \times 10^{-14} u^{\frac{1}{2}} + 9.40 \times 10^{-14} u \text{ cm}^2$, respectively. Here u is the electron energy in electron volts. Mobilities of Kr + and Xe + in helium and in their respective parent gas have also been determined, from the characteristic time constants of the electron density decay measured in the afterglow in the mixtures at low pressures, to be: $\mu(Kr^{+} in He) =$ $2.02 \pm 1.2 \text{ cm}^2/\text{volt-sec}, \mu(\text{Kr}^+ \text{ in Kr}) = 1.01 \pm 0.06, \mu(\text{Xe}^+ \text{ in He}) = 18 \pm 1.1$ and $\mu(Xe^+$ in Xe) = 0.55 + 0.03 at ~ 300°K. A study of the pressure dependence of the characteristic time constants of the electron density decay at fixed ratios of krypton to helium and xenon to helium concentrations yields the three body conversion frequency of atomic krypton and xenon ions to their respective molecular ions.

I. INTRODUCTION

The employment of microwave technology in studying the fundamental atomic collision processes in a weakly ionized gas is well known. Nevertheless, questions have been occasionally raised as to the assumption of thermal equilibrium of the electron gas with the neutrals at times in the afterglow the experiment was performed. In some cases, evidences showed that the electron temperature did sustain at a level above that of the neutrals at times several hundred microseconds to a few milliseconds after removal of the excitation source. Since almost all physical parameters determined by microwave methods are related directly or indirectly to the electron temperature, it would be appropriate that the electron temperature is measured experimentally. In the present communication, the complete thermalization of the electrons with the neutrals in He-Kr and He-Xe mixtures is demonstrated by a comparison of the microwave noise emitted from the plasma with that of a standard noise source as detected by a ruby maser. One of the reasons for mixing krypton and xenon with helium is to utilize the helium as a "recoil" gas for the electrons. Quantitative and qualitative descriptions of various collisional processes are then obtained from the measurements made in the afterglow established in such mixtures. The problems of interest are: (1) the energy dependence of the momentum transfer cross sections of electrons with krypton and xenon atoms at energies below Ramsauer minimum; (2) the mobilities of thermal Kr and Xe ions in helium and in their respective parent gas at room temperature (i.e. ~ 300° K); (3) the conversion frequency v_{conv} of atomic krypton and xenon ions to molecular ions according to the three-body process²



and (4) some qualitative evidence in supporting a suggested process of molecular krypton ions formation, through collisions of high-lying, short-lived excited atoms with ground state atoms,

$$Kr^* + Kr \rightarrow Kr_2^+ + e$$

by Hornbeck and Molnar.³

II. EXPERIMENTAL APPARATUS

The gas handling system is of standard high vacuum type⁴ baked at $\sim 400^{\circ}$ C for more than 24 hours prior to each sequence of experiments. An ultimate vacuum of the order of 2 to 6 x 10⁻¹⁰ mmHg is attained. Gases are then introduced into the discharge tube, and the pressure is measured by a (capacity) null reading manometer.⁵ The gases used are mass spectrometer controlled grade supplied from Linde Air Products Company. The discharge tube is made of thin wall (0.7 mm thick) pyrex tubing of 22 mm outside diameter and 72 cm long with 6 cm tapering to a point at each end. The tube is housed coaxially in a one inch by one inch square waveguide which is connected to the standard x-band waveguide system through two six inch tapering sections. The gas is ionized by a variable high voltage dc pulse of several thousand volts and seven microseconds duration repeated at a frequency of 31.2 cycles per sec. The electrodes of the discharge tube are made out of

high purity titanium for its good gettering property for the atmospheric gases.⁶ Electron density variations and the effective electron collision frequency v_{eff} for momentum transfer are measured by microwave interferometry in the decaying plasma created in helium-krypton and helium-xenon mixtures. A schematic diagram of the microwave circuitry used in part of the experiment is shown in Figure 1. A low power (~ 2 μ w), 9.03 or 8.53 kMc/sec probing signal (continuous or pulsed) is employed to measure the phase shifts and attenuations on the microwave due to the presence of plasma. The temperature of the discharge tube is monitored constantly by three copper-constantan thermocouples.

III. MOMENTUM TRANSFER COLLISION CROSS SECTION

Margenau⁷ has shown that the electrical conductivity σ_c of a weakly ionized gas under the action of a low level rf field is given by

$$\sigma_{c} = \sigma_{r} + j\sigma_{i} = -\frac{ne^{2}}{3m} \int \frac{v \frac{\partial I_{o}}{\partial v}}{v + j\omega} d^{3}v \qquad (1)$$

where σ_r and σ_i are the real and imaginary parts of σ_c . m is the electron mass, e the electron charge, n the electron density and v the electron velocity. ω is the radian frequency of the applied electric field. $v = \sum_{i=1}^{n} N_{m_i} Q_{m_i}(v) v$ is the momentum transfer collision frequency of the electrons with all species in the plasma. Here N_{m_i} is the density of the ith species. In the case of $\omega^2 \gg v^2$ and the electron velocity distribution function to be independent of the proportion of the gas mixture and furthermore f_0 (the zeroth order spherical harmonic expansion of the electron velocity distribution function) to be maxwellian,

$$\sigma_{\rm r} = \frac{{\rm ne}^2}{{\rm m}\omega^2} v_{\rm eff}$$
(2)

)

where

$$v_{\text{eff}} = v_{\text{em}} + v_{\text{em}} + v_{\text{ei}}$$
(3)

is the effective electron collision frequency for momentum transfer. v_{em_1} , v_{em_2} are the electron collision frequencies with gas species 1 and 2, respectively, and

$$v_{\rm em_1} = \frac{{}^{\rm N}_{\rm m_1}}{3} \left(\frac{2}{\pi}\right)^{\frac{1}{2}} \left(\frac{m}{{\rm kT}_{\rm e}}\right)^{5/2} \int_0^\infty Q_{\rm m_1}(v) v^5 \exp\left[-\frac{mv^2}{2{\rm kT}_{\rm e}}\right] dv \tag{4}$$

i = 1, 2. k is the Boltzmann's constant and T_e the electron temperature. Q_{m_1} (v) is the momentum transfer collision cross section of electrons with ith species of atom and is defined⁸ as

$$Q_{m_i}(v) = \int (1 - \cos\theta) I(\theta, v) d\Omega$$

where $I(\theta, v)$ is the differential scattering cross section for a scattering angle θ and relative velocity v.⁹ v_{ei} is the electron-ion collision frequency and is represented by¹⁰

$$p_{ei} = 3.59 \frac{N_i}{T_e^{3/2}} \ln \frac{3.32 \times 10^3 T_e^{3/2}}{N_i^{\frac{1}{2}}}$$
(5)

where N_i is the ion density. In our experiments, v_{ei}/v_{eff} is of the order of 1 to 10% in the afterglow in which v_{eff} is measured. If we define $v_{em} = v_{em} + v_{em}$, then it is easily shown that

$$\frac{v_{\text{em}}}{p_{\text{t}}} = \left[\frac{v_{\text{em}}}{p_{1}} - \frac{v_{\text{em}}}{p_{2}}\right] \frac{p_{1}}{p_{\text{t}}} + \frac{v_{\text{em}_{2}}}{p_{2}}$$
(6)

where p_t is the total gas pressure and is equal to the sum of the partial pressures p_1 and p_2 of the mixtures. All pressures are hereafter referred to 0°C. Therefore, the ratio of measured electron-molecule collision frequency

to the total gas pressure is a linear function of fractional concentration of gas 1 at a fixed temperature. v_{em_1}/p_1 and v_{em_2}/p_2 are determined from the intersections at $p_1/p_t = 1$ and 0, respectively. Q_{m_1} (v) can then be determined experimentally from Eq (4) should there be enough data of v_{em_1}/p_1 as a function of temperature is provided.

IV. ION MOBILITIES AND CONVERSION FREQUENCIES

The main electron loss process in the afterglow of a low pressure, weakly ionized noble gaseous discharge is ambipolar diffusion.¹¹ For the present experiments (helium-krypton or helium-xenon mixtures of various proportions) the ions created in the active discharge are believed to be atomic krypton or xenon ions when suitable breakdown voltage pulse is employed. ¹² This is supported by the spectral examination of the discharge in He-Kr mixtures with a Bausch and Lomb Littrow No. 5402 Spectrograph which has a dispersion of 7.7 A/mm at 3670 A and 45.5 A/mm at 6700 A. It is found that no band spectra of any kind and only atomic krypton lines are presented. Hornbeck and Molnar³ noticed in their mass spectrometric studies of molecular ions in noble gases that Kr_2^+ and Xe_2^+ ions are much more difficult to be formed than He_2^+ , Ne_2^+ , and A_2^+ through a process suggested by them. At low gas pressures and careful breakdown conditions,¹² the molecular ion formation process proposed by Hornbeck and Molnar³ can be ignored. However, another mechanism seems to be possible for their formation. That is, Kr or Xe ions, while traversing through the mixture to the walls in a decaying plasma, experience not only elastical scatterings from helium and their parent gas atoms, but also may change their identities to molecular ions through three-body collisions

$$Kr^{+} Kr Kr_{2}^{+}$$

$$+ He \rightarrow + He (7)$$

$$Xe^{+} Xe Xe_{2}^{+}$$

The differential equations governing the decaying plasma are

$$\frac{\partial n_{A}}{\partial t} = D_{aA} \nabla^{2} n_{A} - v_{conv} n_{A}$$
(8a)

$$\frac{\partial n_{M}}{\partial t} = D_{aM} \nabla^{2} n_{M} + v_{conv} n_{A}$$
(8b)

$$n = n_{A} + n_{M} \tag{8c}$$

Here electron decay through recombinations has been neglected in this case for its ineffectiveness.¹³ n_A and n_M are the number densities of the atomic and molecular ions, respectively. D_{aA} and D_{aM} are the ambipolar diffusion coefficients of the atomic and molecular ions in the mixtures and $v_{conv} =$ $C_{conv}p_1p_2$ is the atomic to molecular ion conversion frequency according to reaction (7). The conversion coefficient C_{conv} is a constant and is different for Kr⁺ than for Xe⁺. The set of equations is solved for the boundary conditions of zero densities for all constituents at the walls.

The solution for the electron density is

$$n(t) = n_{A}(0) \left[1 - \frac{v_{conv}}{\frac{1}{T_{A}} - \frac{1}{\tau_{M}}} \right] \exp \left[- \frac{t}{\tau_{A}} \right]$$

+
$$\left[n_{M}(0) + \frac{n_{A}(0)v_{conv}}{\frac{1}{\tau_{A}} - \frac{1}{\tau_{M}}} \right] \exp \left[- \frac{t}{\tau_{M}} \right]$$
(9)

where

$$\frac{1}{\tau_{A}} = \frac{D_{aA}}{\Lambda^{2}} + v_{conv}$$
(10)

6

and

$$=\frac{D_{AM}}{\Lambda^2}$$
(11)

A is the characteristic diffusion length of the discharge tube. Since $v_{\rm conv}$ is proportional to the square of the gas pressure, $v_{\rm conv} \left[\frac{1}{T_A} - \frac{1}{T_M} \right]^{-1} < < 1$ at low pressures. This together with the initial condition $n_M(0) \simeq 0$ (see section V) and the fact that $\tau_M < \tau_A$ (due principally to the lack of charge transfer process of the molecular ions with the neutrals) gives the final slope of &n n versus t plot to be - τ_A^{-1} . It is easy to show from Eq (10) that the product of ambipolar diffusion coefficient D_a of electrons to the partial pressure of helium in the helium-krypton mixtures, for example, takes the following form

1 T_M

$$D_{a}p(He) = \frac{T_{e}}{7.63} \frac{\mu(Kr^{+} \text{ in He})}{1 + \frac{p(Kr)}{p(He)} \frac{\mu(Kr^{+} \text{ in He})}{\mu(Kr^{+} \text{ in Kr})}} + \Lambda^{2}C_{conv}p^{2}(He)p(Kr)$$
(12)

where $\mu(\text{Kr}^+ \text{ in He})$ and $\mu(\text{Kr}^+ \text{ in Kr})$ are the mobilities of atomic krypton ions in helium and in krypton, respectively, referred to 0°C and 760 mmHg gas pressure. p(Kr) and p(He) are the partial pressures of krypton and helium in the mixtures. In deriving Eq (12), Einstein's relation¹⁴

$$D = \frac{kT}{e} \mu$$

and Blanc's law¹⁵

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$$\frac{1}{\mu} = \frac{p(Kr)}{p_t} \frac{1}{\mu(Kr^+ \text{ in } Kr)} + \frac{p(He)}{p_t} \frac{1}{\mu(Kr^+ \text{ in } He)}$$

have been employed. Here μ is the mobility of Kr⁺ ions in helium-krypton mixture. Mobilities of Kr⁺ ions in helium and in krypton and the proportionality constant C_{conv} in the conversion frequency can be determined from a

and

best fit of $D_{a}p(He)$ as a function of p(Kr)/p(He) according to Eq (12). Similar treatment can be applied in the case of helium-xenon mixtures.

V. RESULTS AND DISCUSSIONS

One of the crucial parameters in studying atomic processes in a decaying plasma by microwave is the electron temperature. Radiometer 16 has been used in the past to study the electron temperature decay in an afterglow. Evidences 17 showed, in some cases, that electrons did sustain at a temperature much higher than that of the gas even several hundred microseconds in the post-discharge. To bring down the electron temperature to that of the gas quickly in the afterglow, Biondi¹⁸ employed helium as a "recoil" gas. That helium gas is added to krypton and xenon in the present experiment is just for this purpose. The electron temperature relaxation after termination of the breakdown pulse in the present experiment is observed by a ruby maser operating at a pump frequency of \sim 21 kMc/sec and a signal frequency of 8.53 kMc/sec to monitor the noise emanating from the discharge tube. A standard noise source is used for comparison. The maser has a gain of ~ 25 db. A typical example is shown in Fig. 2. In this case, a plasma is created by a high voltage pulse in helium-xenon mixture of 54.6% xenon and a total pressure of 4.83 mmHg. The background gas temperature is 303°K. Fig. 2b is the picture of the transmitted microwave signal. It remains cut off up to 450 usec in the afterglow. In this time interval, no reflection is detected and the absorptivity of the plasma is unity. A direct comparison of the noise emitted by the plasma with a standard noise source, as shown in Fig. 2a, indicates that the electron temperature has reached that of the gas approximately

300 μ sec after termination of the pulse. Fig. 2c is the microwave interferometer trace from which the decay of electron density is calculated.

It is shown in Eq (6) that the ratio of total measured electronmolecule collision frequency to the gas pressure is a linear function of the fractional concentration of either gas in a binary mixture at constant temperature. This is confirmed in the experiments of He-Kr and He-Xe mixtures at 200 and 303°K, under the condition of $\left(\frac{00}{V}\right) \gg 1$ (usually $\left(\frac{00}{V}\right)^2 \simeq 100$ in the present experiment). The results are shown in Figures 3 and 4. From the extrapolated values of v_{em}/p_t at $p(Kr)/p_t$ and $p(Xe)/p_t = 0$ and 1, the momentum transfer collision probability \overline{P}_m^{-19} of electrons with He, Kr, and Xe atoms are calculated at these two temperatures. They are: 18.9, 54.7, and 151 cm²/cm³, respectively, at 303°K and 18.9, 77.5, and 221 cm²/cm³, respectively, at 200°K. Thus, within experimental accuracy, \overline{P}_m (He) and hence $Q_m(v)$ for He is a constant in this range. This fact agrees with what has been found by other investigators²⁰ and is utilized later on in deducing $v_{em}(Kr)/p(Kr)$ and $v_{em}(Xe)/p(Xe)$ from v_{eff}/p_t measured at higher temperatures. The temperature dependence of $v_{em}(He)/p(He)$ is taken to be

$$\frac{v_{\rm em}({\rm He})}{p({\rm He})} = 1.56 \times 10^7 {\rm T_e}^{\frac{1}{2}} {\rm sec}^{-1} {\rm -mmHg}^{-1}$$
(13)

By subtracting electron-ion (as calculated from Eq (5)) and electron-helium (as calculated from Eq (13)) contributions from v_{eff} , the resulting momentum transfer collision frequency of electrons with Kr and Xe atoms as a function of electron temperature is shown in Figures 5 and 6. The velocity dependence of the momentum transfer cross section $Q_m(v)$ is determined from a best fit to the experimental points according to Eq (4). In so doing, $Q_m(v)$ is assumed by a three term polynomial of the following form

$$Q_{\rm m}(v) = A + Bv + Cv^2 cm^2$$

The solid curves on Figures 5 and 6 are so found with

 $A = 6.56 \times 10^{-15} \text{ cm}^2$ $B = -4.70 \times 10^{-22} \text{ cm-sec}$ $C = 8.87 \times 10^{-30} \text{ sec}^2$

for krypton and

$$A = 1.91 \times 10^{-14} \text{ cm}^2$$

$$B = -1.40 \times 10^{-21} \text{ cm-sec}$$

$$C = 2.67 \times 10^{-29} \text{ sec}^2$$

for xenon. Then the energy dependence of these cross sections can easily be shown to be

 $Q_{\rm m}(u) = 6.56 \times 10^{-15} - 2.79 \times 10^{-14} u^{\frac{1}{2}} + 3.14 \times 10^{-14} u \ {\rm cm}^2$ (14) for krypton and

$$Q_{\rm m}(u) = 1.91 \times 10^{-14} - 8.30 \times 10^{-14} u^{\frac{1}{2}} + 9.40 \times 10^{-14} u \ {\rm cm}^2$$
 (15)

for xenon. Here u is the electron energy in electron volts.

Recently, Pack, Volshall and Phelps (PVP)²¹ have deduced $Q_m(u)$ from their electron mobility studies in Kr and Xe. Their results, together with the present one, are shown in Figures 7 and 8. In which PVP's notations are preserved. O'Malley²² has adopted "atomic effective range formulas"²³ to analyze Ramsauer-Kollath (RK) scattering experiments.²⁴ In this analysis, the parameters of the theory are so chosen to fit RK experimental cross sections. These calculations were extrapolated to zero energy and are shown in Figures 7 and 8. All agree fairly well with each other in shape but not in absolute value. The disagreements can be attributed partly to the approximations and experimental errors in each case.

In Section IV it is shown that at low gas pressures and suitable breakdown conditions the ultimate inverse characteristic time constant of the electron density decay is given by Eq (10) from which Eq (12) is derived. Since the second term to the right hand side of Eq (12) is proportional to the third power of the total gas pressure, and can be neglected at very low gas pressures, i.e.,

$$D_{a}p(He) = \frac{T_{e}}{7.63} \frac{\mu(Kr^{+} \text{ in He})}{1 + \frac{p(Kr)}{p(He)} \frac{\mu(Kr^{+} \text{ in He})}{\mu(Kr^{+} \text{ in Kr})}}$$
(16)

 $\mu(\text{Kr}^+ \text{ in He})$ and $\mu(\text{Kr}^+ \text{ in Kr})$ are then determined from the best fit of the measured quantities $D_a p(\text{He})$ and p(Kr)/p(He) at a constant temperature according to Eq (16). This is shown in Figure 9 and the results are: $\mu(\text{Kr}^+ \text{ in He}) = 20.2 \pm 1.2 \text{ cm}^2/\text{volt-sec}$ and $\mu(\text{Kr}^+ \text{ in Kr}) = 1.0 \pm 0.06$ at 303° K. Figure 10 shows the results in the case of He-Xe mixtures, the best fit gives: $\mu(\text{Xe}^+ \text{ in He}) = 18 \pm 1.1$ and $\mu(\text{Xe}^+ \text{ in Xe}) = 0.55 \pm 0.03$ at 303° K.

The theoretical calculated mobilities of thermal energy ion relevant to the present experiment, together with the values determined by other authors, are presented in Table I. The theoretical values of $\mu(Kr^+$ in He) and $\mu(Xe^+$ in He) are calculated by the use of Langevin's theory in the polarization limit.²⁵ The dielectric constant for helium adopted here is that recommended by Maryott and Buckley.²⁶

A close examination of Eq (12) suggests that, for a fixed percentage of krypton (or xenon) in helium, the measured values of $D_a p(He)$ should vary linearly with $p^2(He)p(Kr)$ should there be the three-body molecular ion formation process. The slope of $D_a p(He)$ versus $p^2(He)p(Kr)$ yields the value of $C_{conv}\Lambda^2$, and it is independent of the krypton percentage in helium. Figure 11 presents the results in four different krypton percentages, i.e., 1.7, 4.3, 5.97, and 14%. The slopes are fairly well the same, and C_{conv} so determined is (76 ± 4) mmHg⁻² sec⁻¹ and

$$v_{conv} = (76 \pm 4)p(He)p(Kr)$$

Similar studies are also made for Xe⁺ to Xe⁺₂ conversion. Typical results are shown in Figure 12. In this case, $C_{conv} = (140 \pm 9) \text{ mmHg}^{-2} \text{sec}^{-1}$ and

 $v_{\rm conv} = (140 \pm 9)p({\rm He})p({\rm Xe}).$

Similar to the gas-kinetic conditions²⁷ in two-body charge or excitation transfer collisions, it is reasonable to believe that the lesser the amount of energy carried away by the third body in reaction (7), the higher the probability of molecular ion formation. Then the larger value of C_{conv} , which is proportional to the probability, for Xe^+ to Xe_2^+ than Kr^+ to Kr_2^+ indicates that the amount of energy carried away by He is smaller in the former than in the latter case. Should this be so, the binding energy of Xe_2^+ would be smaller than that of Kr_2^+ . This has to wait a further study in appearance potentials in these gases to confirm it. Nevertheless, observations by Hornbeck and Molnar³ seemed to suggest the same explanation. They noticed, in their mass spectrometry studies of molecular ions formed by electron bombardment in noble gases, that the current peaks of Xe^+ to Xe_2^+ is 4×10^4 to 1 while Kr^+ to Kr_2^+ is 2 ×10⁴ to 1. The apparent more difficulty in Xe_2^+ formation than Kr_2^+ through (taking xenon as an example)

$$e + Xe \rightarrow Xe^* + e$$
 (17a)

$$Xe^{*} + Xe \rightarrow Xe_{2}^{+} + e$$
 (17b)

could be explained as that Xe^{*} (stands for xenon atom in a high-lying, short-lived excited state) required for the reaction must be very close to the ionization limit if the binding energy of Xe⁺₂ were very small. The excitation cross section is known to drop off rapidly in general as the total quantum number increases.²⁷ Therefore, their finding seems to be in harmony with C_{conv} determined here.

We have also studied qualitatively the molecular ion formation processes proposed by Hornbeck and Molnar³ [see Eqs (17a) and (17b)]. We observe (see Figures 13, 14) that the characteristic time constant of the electron density decay is a strong function of the excitation light in the active discharge, while keeping p, and the relative concentration of Kr unchanged. Qualitatively, the brighter the excitation light (indicated in Figures 13 and 14 by the higher breakdown voltage pulse setting) the smaller the characteristic ambipolar diffusion time constant. Since electrons have already relaxed back to the gas temperature at times in the afterglow the measurements were made and high order modes of diffusion are believed not to exist at such late times in the afterglow. The only feasible explanation offered to such phenomenon is the formation of molecular ions through processes (17a) and (17b). Xe_2^+ or Kr⁺₂ ions are known to have a higher mobility than Xe⁺ or Kr⁺ in their parent gases. The light intensity in the active discharge is interpreted as an indirect measure of Xe or Kr concentrations. No detailed correlations between the distribution of line intensities and the molecular ion concentrations are pursued at the present time. Further mass- and optical spectrometry studies are necessary.

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	on Kr	Kr ⁺		xe ⁺	
Gas Mobil	ity Experiment	Theory	Experiment	Theory	
He	20.2 <u>+</u> 1.2 ^a	17.0	18 <u>+</u> 1.1 ^a	16.8	
Kr	0.9-0.95 ^b 0.90 ^c 1.01 <u>+</u> 0.06 ^a	1.0 ^d 0.9 ^e			
Xe			0.6-0.65 ^b 0.58 ^c 0.55 <u>+</u> 0.03 ^a	0.66 ^d 0.60 ^e	

Table I. Comparison of Experimental and Theoretical Values of Kr^+ and Xe^+ Mobilities (in $cm^2/volt$ -sec).

a. Present data

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19. From Eqs (1) and (2), it can easily be shown that $v_{eff} = \frac{4}{3} N_m \overline{Q}_m \langle v \rangle$, where \overline{Q}_m is the effective momentum transfer cross section and $\langle v \rangle = (8kT_e/m)^{\frac{1}{2}}$. Then the effective momentum transfer collision probability \overline{P}_m is given by $\overline{P}_m = \frac{3}{4} \frac{v_{eff}}{\langle v \rangle}$.

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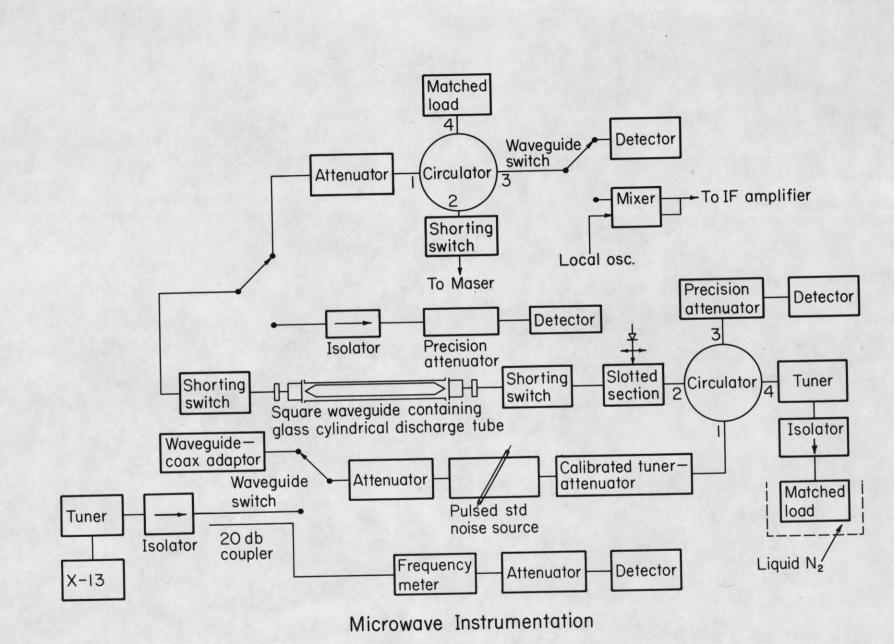


Figure 1. Schematic diagram of one of the microwave circuitries employed in the present experiment.



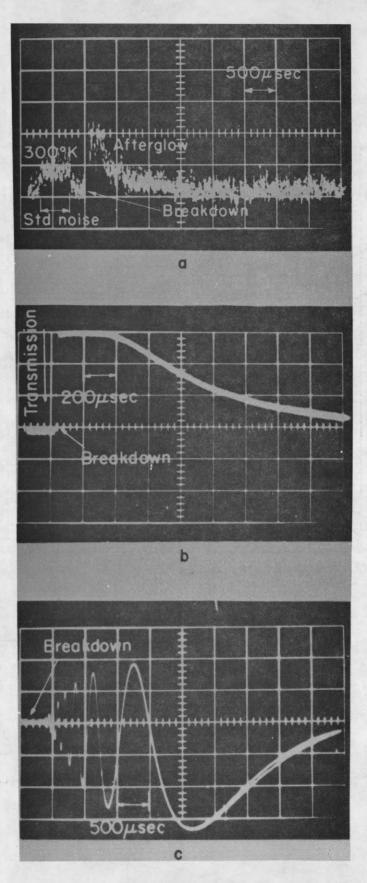


Figure 2. Noise and microwave measurements in He-Xe mixture of 54.6% Xe and a total pressure of 4.83 mmHg. (a) Direct comparison of the noise emitted by the decaying plasma with that from a standard noise source of 300°K.
(b) Microwave signal (8.53 kMc/sec) transmitted through the decaying plasma.
(c) Microwave interferometer trace.

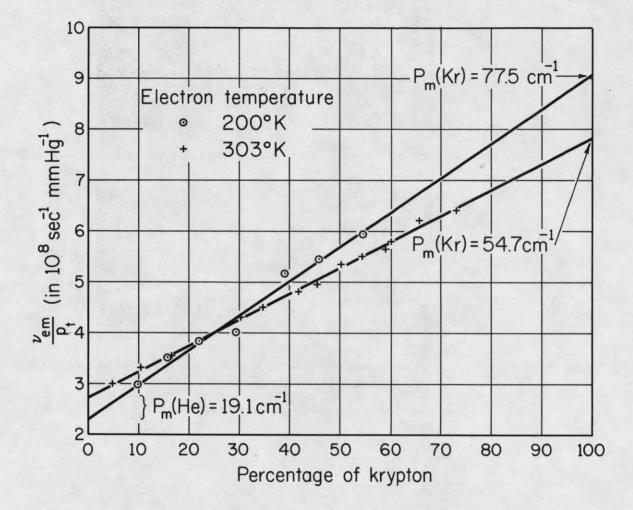


Figure 3. v_{em}/p_t versus percentage of krypton in heliumkrypton mixtures at 200 and 303°K. The straight line behavior is predicted by Eq (6) in the text under the condition of $(\frac{v}{\omega})^2 \ll 1$. The two ordinates of v_{em}/p_t at 0 and 100% Kr give v_{em} (He)/p(He) and v_{em} (Kr)/p(Kr) at the temperatures indicated.

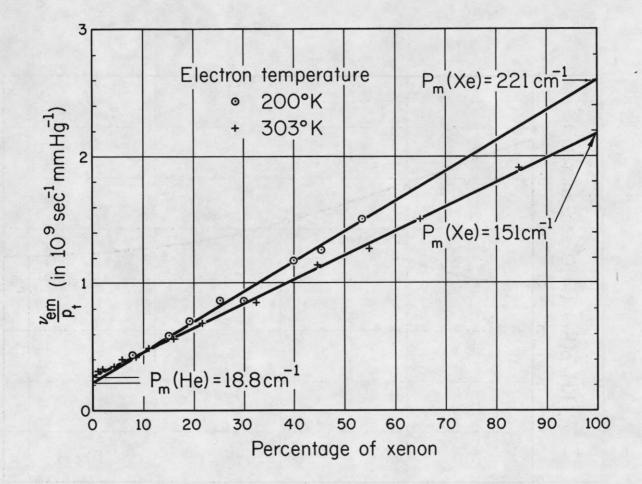


Figure 4. v_{em}/p_t versus percentage of xenon in helium-xenon mixtures at 200 and 303°K. The straight line behavior is predicted by Eq (6) in the text under the condition of $\left(\frac{v}{w}\right)^2 \ll 1$. The two ordinates of v_{em}/p_t at 0 and 100% Xe give v_{em} (He)/p(He) and v_{em} (Xe)/p(Xe) at the temperatures indicated.

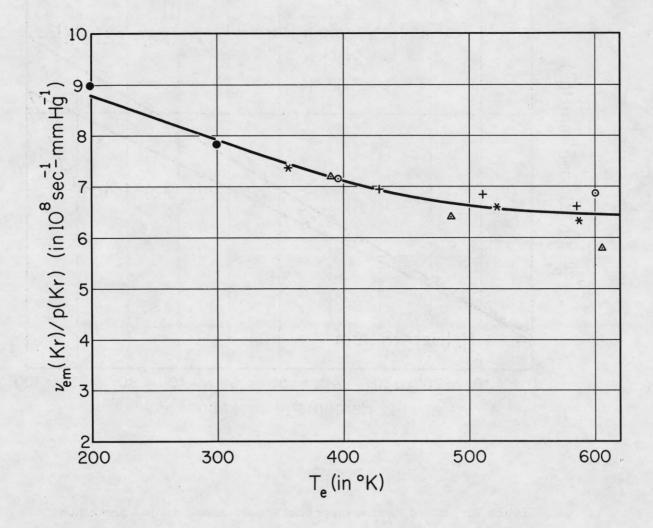


Figure 5. $v_{em}(Kr)/p(Kr)$ versus T_e . The various symbols on the graph represent the values of $v_{em}(Kr)/p(Kr)$ deduced from different fractional krypton concentrations: • from Fig. 3, * 41.6% Kr, • 50.1% Kr, + 58.8% Kr, Δ 73% Kr. The solid curve is the best fit to the experimental points according to Eq (4) and assuming $Q_m(v) = A + Bv + Cv^2$.

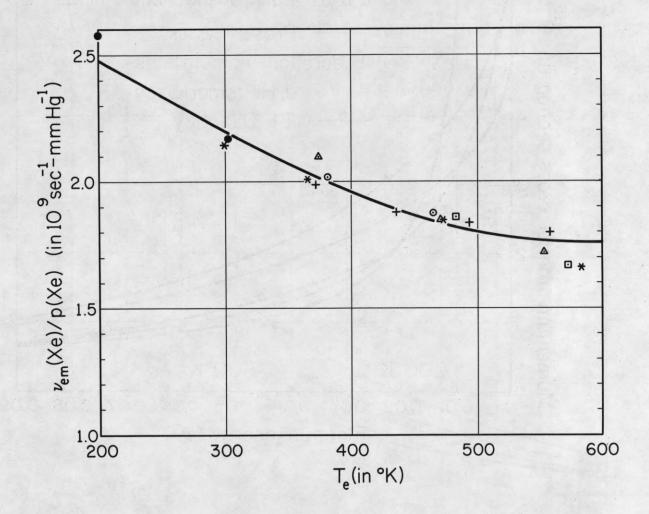


Figure 6. $v_{em}(Xe)/p(Xe)$ versus T_e . The various symbols on the graph represent the values of $v_{em}(Xe)/p(Xe)$ deduced from different fractional xenon concentrations: • from Fig. 4, + 50% Xe, • 58.8% Xe, • 73.4% Xe, Δ 84.9% Xe, * 93% Xe. The solid curve is the best fit to the experimental points according to Eq (4) and assuming $Q_m(v) = A + Bv + Cv^2$.

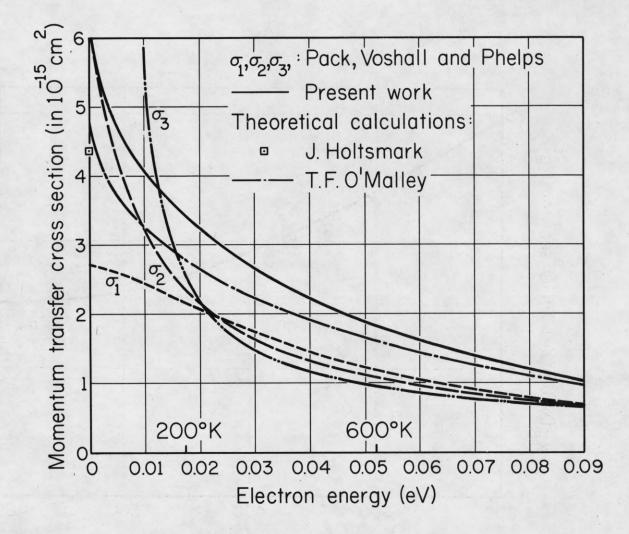


Figure 7. Momentum transfer cross section of electrons with krypton atoms. The result of the present experiment is compared with those found by PVP and the theoretical calculations by O'Malley.

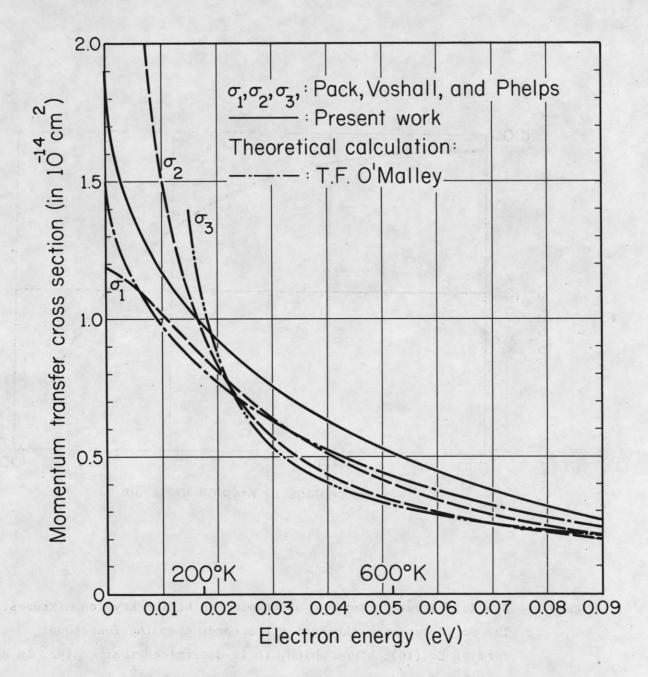


Figure 8. Momentum transfer cross section of electrons with xenon atoms. The result of the present experiment is compared with those found by PVP and the theoretical calculations by O'Malley.

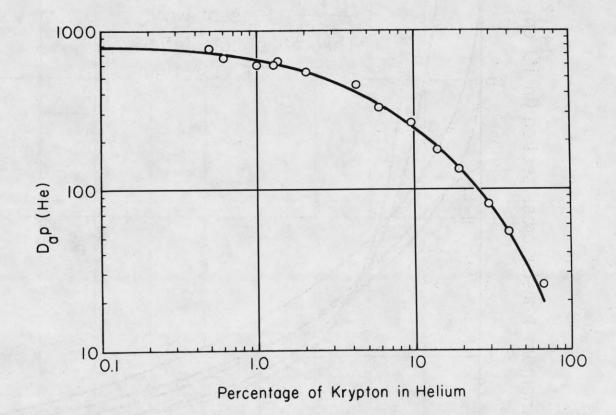


Figure 9. $D_a p(He)$ versus percentage of krypton in helium-krypton mixtures. The solid curve is the best fit according to the functional form of Eq (16). From which, it is determined that: $\mu(Kr^{+} \text{ in He})$ = 20.2[±]1.2 cm²/volt-sec and $\mu(Kr^{+} \text{ in Kr}) = 1.01^{\pm}0.06$.

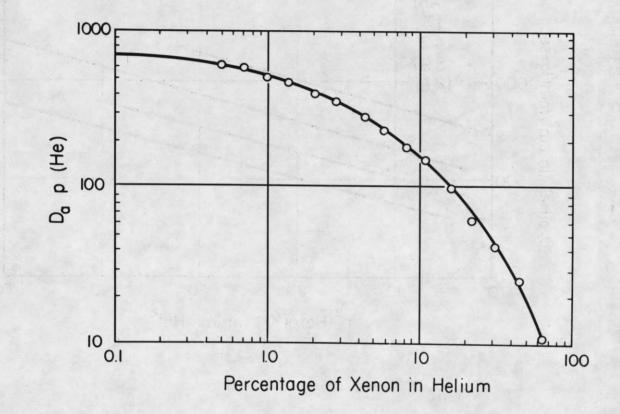


Figure 10. $D_{a}p(He)$ versus percentage of xenon in helium-xenon mixtures. The solid curve is the best fit according to the functional form of Eq (16). From which, it is determined that: $\mu(Xe^{+} \text{ in He}) =$ $18 \pm 1.1 \text{ cm}^{2}/\text{volt-sec}$ and $\mu(Xe^{+} \text{ in Xe}) = 0.55 \pm 0.03$.

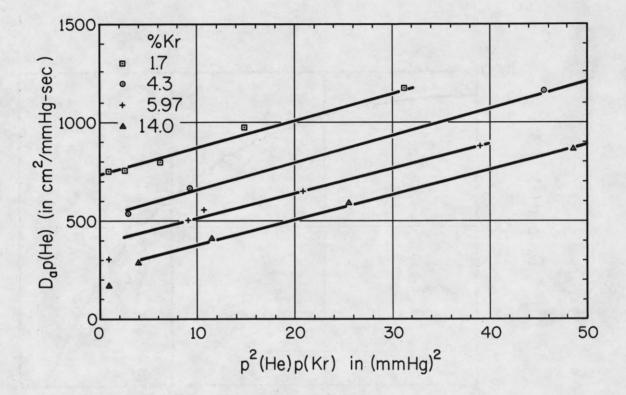
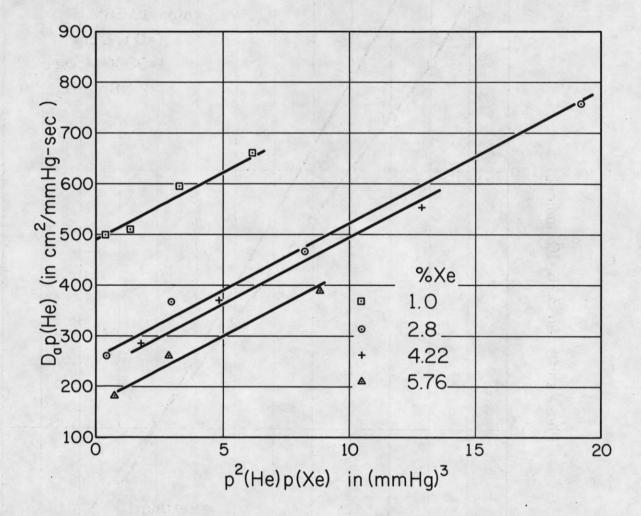
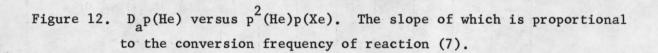


Figure 11. $D_{a}p(He)$ versus $p^{2}(He)p(Kr)$. The slope of which is proportional to the conversion frequency reaction (7).





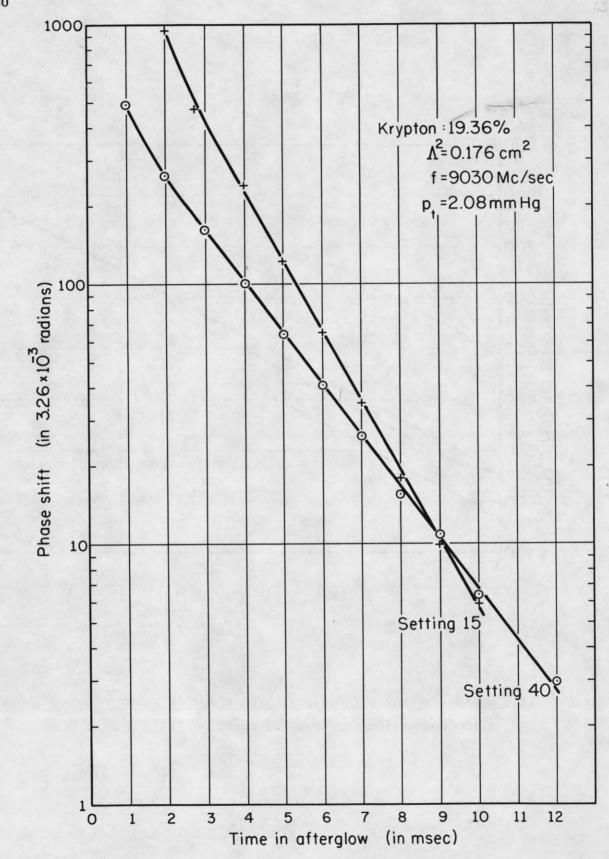


Figure 13. Electron density decay for two different breakdown voltage strengths in helium-krypton mixtures. The settings indicate the relative strength.

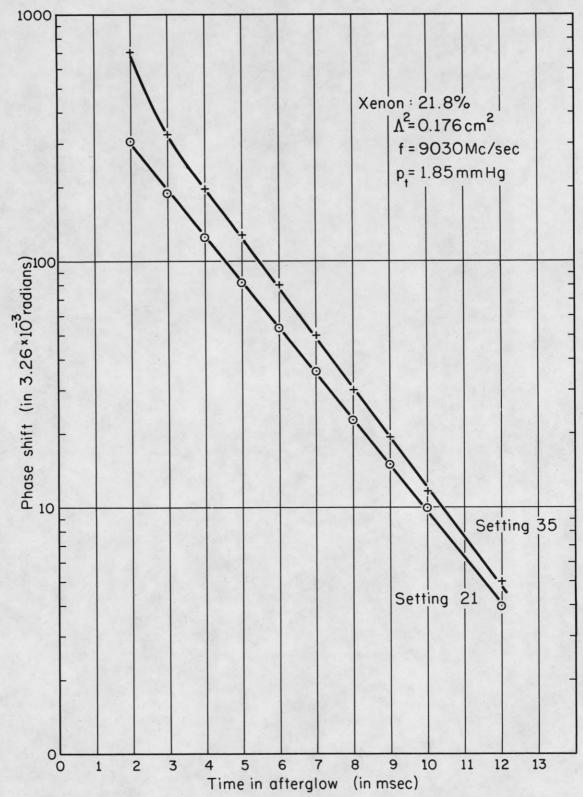


Figure 14. Electron density decay fro two different breakdown voltage strengths in helium-xenon mixtures. The settings indicate the relative strength.

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